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34	405
Class	Subclass
ISSUE CLASSIFICATION	

PATENT NUMBER

U.S. REISSUE Patent Application

O.I.P.E. AK SCANNED <u>LM</u> Q.A. <u>LA</u>	O.G. PUBLICATION DATE	REISSUE PATENT DATE
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APPLICATION NO. 107060304	CONT/PRIOR D F	CLASS 034	SUBCLASS 444	ART UNIT 3749	EXAMINER WILSON, TAM
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APPLICANTS

Shigekazu Kato
Kouji Nishihata
Tsunehiko Isubone
Atsushi Ito

~~for~~ with wafers, substrates and/or Semiconductors

~~Vacuum processing apparatus and operating method therefor~~

TITLE

PAN 8/31/03

PTO-2040
12/99

☒ SURRENDER OF ORIGINAL PATENT: KSE (Exr. Initials)

ORIGINAL PATENT NUMBER 6,330,756

[illegible]

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS Sheets Draw. <u>1</u> Figs. Draw. <u>2</u> Print Fig. <u>1</u>		CLAIMS ALLOWED Total Claims <u>0</u> Print Claim for O.G. <u>9</u>	
	<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.		NOTICE OF ALLOWANCE MAILED	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S. Patent. No. _____	<u>Watson</u> <u>6/12/04</u> (Assistant Examiner) (Date)		ISSUE FEE	
	<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.		Amount Due Date Paid	
FINAL SPRE REVIEW <u>[Signature]</u> (INITIALS)	<u>[Signature]</u> Supervisory Patent Examiner Group 37 (in) (Primary Examiner) (Date) <u>6/14/04</u>		ISSUE BATCH NUMBER	
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